



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Hans Wilfried Peter Koops  
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Title: **PROCEDURE FOR ETCHING OF MATERIALS AT THE SURFACE  
WITH FOCUSED ELECTRON BEAM INDUCED CHEMICAL  
REACTION AT SAID SURFACE**

10 Application Serial No. : 10/628,174

Filing Date: July 28, 2003

15 Assignee: NaWoTec GmbH

Priority claimed: October 16, 2002, European Patent No. 02 023 217.9

AMENDMENT

20 This amendment is in response to Office Action dated October 14, 2005. A petition for a two month extension and fee is being submitted herewith. Reconsideration of claims 1-3 and 19-41 is respectfully requested.

25 Petition is hereby made for a two-month extension of the period to respond to the outstanding Official Action. A check in the amount of \$450.00, as the Petition fee, is enclosed herewith. If there are any additional charges, or any overpayment, in connection with the filing of the amendment, the Commissioner is hereby authorized to charge any such deficiency, or credit any such overpayment, to Deposit Account 23-3060.

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03/17/2006 WABDELRI 00000077 10628174

01 FC:1252 450.00 OP

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03/17/2006 WABDELRI 00000077 10628174

02 FC:1806 180.00 OP

Respectfully submitted,

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